

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Hiroki SHINKAWATA

Serial No.:

Group Art Unit:

Filed: January 23, 2001

Examiner:

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING SAME

INFORMATION DISCLOSURE STATEMENTCommissioner for Patents  
Washington, DC 20231#3  
D. Scott  
5-18-01

Dear Sir:

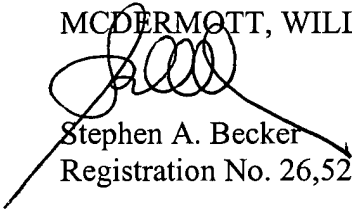
In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference is accompanied by an English abstract.

Respectfully submitted,

MCDERMOTT, WILL &amp; EMERY

  
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